

Form PTO-1449 (MODIFIED)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 039153-0448 (G1153)	SERIAL NO. Unknown
INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>		APPLICANT	Lukanc et al.
		FILING DATE	GROUP ART UNIT
		Unknown	Unknown

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE IF APPROPRIATE
	A1	00/772,5277		Todd Lukanc			01/30/2001
<i>DL</i>	A2	6,228,539 B1	05/08/2001	Wang et al.	430	5	
	A3	5,858,580	01/12/1999	Wang et al.	430	5	
	A4	5,807,649	09/15/1998	Liebmann et al.	430	5	
<i>DL</i>	A5	5,573,890	11/12/1996	Spence	430	311	
<i>DL</i>		6,534,224	11/30/2001	Lukanc	430	5	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>DL</i>	A6	Levenson et al., "Improving Resolution in Photolithography with a Phase-Shifting Mask," IEEE Transactions On Electron Devices, Vol. ED-29, No. 12, December 1982, pp. 1828-36.
<i>DL</i>	A7	Lin, B. J., "Phase-Shifting Masks Gain an Edge," Circuits & Devices, March 1993, pp. 28-35.

EXAMINER	DATE CONSIDERED
<i>Dosasco</i>	9/10/03

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any copy of this form with next communication to applicant.